Tutorial Sheet No. 2

- 1. Calculate the threshold voltage of NMOS with V_{SB} =0,for a poly-Si gate. Substrate doping density= 10^{16} /cm³, Poly-Si gate doping density= $2x10^{20}$ /cm³. Gate oxide thickness=500Å. Oxide charge density = $4x10^{10}$ / cm². (ϵ_{ox} = 3.97, ϵ_{Si} = 11.7)
- 2. Consider an n+ poly-Si gate and a p type Si substrate doped with $3x10^{16}/cm^3$. Assume $N_{ox}=10^{11}/cm^2$. Determine the oxide thickness such that $V_{T0}=0.65V$. ($\not O_{GC}=-1.13V$)
- 3. Calculate the threshold voltage of n-mos with Al gate where $N_A=10^{14}/$ cm³, $Nox=10^{10}/$ cm², $t_{ox}=500$ Å, $\emptyset_{GC}=$ -0.83V. Also discuss the answer.
- 4. Consider a MOS device with following parameters: poly-Si gate doping density $N_D=10^{20}/cm^3$, n type substrate $N_D=10^{15}/cm^3$, tox=650 Å, $N_{ox}=2x10^{10}/cm^2$. Find V_{T0} of the transistor.